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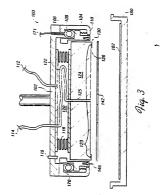
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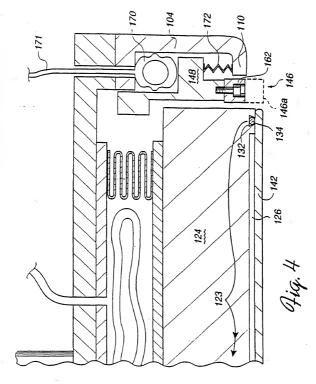
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(54)Apparatus for holding a substrate during polishing

A water polishing head (100) utilises a water backing member (124) having a wafer facing pocket (126) which is sealed against the water and is pressurised with air or other fluid to provide a uniform force distribution pattern across the width of the wafer inside an edge seal feature (123) at the perimeter of the wafer to urge (or press) the wafer uniformly toward a polishing pad (182). Wafer polishing is carried out uniformly without variations in the amount of wafer material across the usable area of the water. A frictional force between the seal feature (123) of the backing member and the surface of the wafer transfers rotational movement of the head to the wafer during polishing. A pressure controlled bellows (118) supports and presses the wafer backing member (124) toward the polishing pad (182) and accommodates any dimensional variation between the polishing head and the polishing pad as the polishing head is moved relative to the polishing pad. An integral, but independently retractable and extendable retaining ring assembly (146) is provided around the wafer backing member and wafer to uniformly an independently control the pressure of a wafer perimeter retaining ring (162) on the polishing pad (182) of a wafer polishing bed (180)





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EUROPEAN SEARCH REPORT

EP 96 30 4118

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ategory	Citation of document with indi	cation, where appropriate,	Relevant to clasm	CLASSIFICATION OF THE APPLICATION (Int.CL6)	
1	PATENT ABSTRACTS OF vol. 010, no. 176 (M & JP-A-61 025768 (NE 1986, * abstract *	-491). 20 June 1986	1,11,18, 22,39		
`	1988, * abstract *	JAPAN -809), 4 April 1989 TACHI LTD), 8 December	1,11,18, 22,39		
				TECHNICAL FIELDS SEARCHED (Inc.Cl.6)	
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_	The present search report has b	ees drawn up for all claims	1		
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	THE HAGUE	27 November 199	6 Ga	rella, M	
A:	CATEGORY OF CITED DOCUME particularly relevant if taken alone particularly relevant if combined with an document of the same category technological background son-written disclosure intermeduate document	E : earlier patent after the film b: document cite L : document cite	g date ed in the applicati ed for other reason	e investion blisbed on, or	

2.



European Patent Office

EP 96 30 4118 - B -

LACK OF UNITY OF INVENTION

The Search Division considers that the present European patent application does not comply with the requirement of unity of invention and relates to several inventions, namely:

1. Claims 1-4,8-14,18-46 : A substrate polishing apparatus having a backing

member with a sealed pocket and a method of

polishing a substrate.

Claims 5-7,17 A substrate polishing apparatus having a retaining

ring assembly.

3. Claims 15,16 A substrate polishing apparatus having a hallows.

A substrate polishing apparatus having a bellows member.



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EUROPEAN SEARCH REPORT

Application Number EP 96 30 4118

	DOCUMENTS CONS	IDERED TO BE RELEVA	NT	
Category	Citation of document with of relevant p	indication, where appropriate, assages	Relevant to claim	CLASSIFICATION OF THE APPLICATION (Int.Cl.6)
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	figure *	,		
Υ			2,8,13, 14,16, 19-21, 32-46	
Y	March 1987	OGOVEN GROEP 8.V.) 5	2	
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о,х	US-A-5 205 082 (SHE	ENDON ET AL.) 27 April	5,17	
Y		<u>-</u> line 60; figures *	8,13,14, 16,32-38	
Ý.	RESEARCH DISCLOSURE no. 322, 1 Februar page 95 XP000168310 HOLDER FOR UNIFORM * the whole documer	y 1991, PRESSURIZED WAFER POLISHING"	19-21, 39-46	TECHNICAL FIELDS SEARCHED (Int.Cl.6) B248
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	Place of warch	Date of completion of the search	6 6-	ella. M
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	SECRET CLAIMS:				
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